

Notice of References Cited	Application/Control No. 10/648,340	Applicant(s)/Patent Under Reexamination OGISHIMA ET AL.	
	Examiner W. Patty Chen	Art Unit 2871	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,567,144	05-2003	Kim et al.	349/128
*	B	US-2001/0019388	09-2001	Kim et al.	349/129
	C	US-			
	D	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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